Supporting Information

Advanced carbon based materials for fabrications of sodium ion hybrid capacitors with high electrochemical performance

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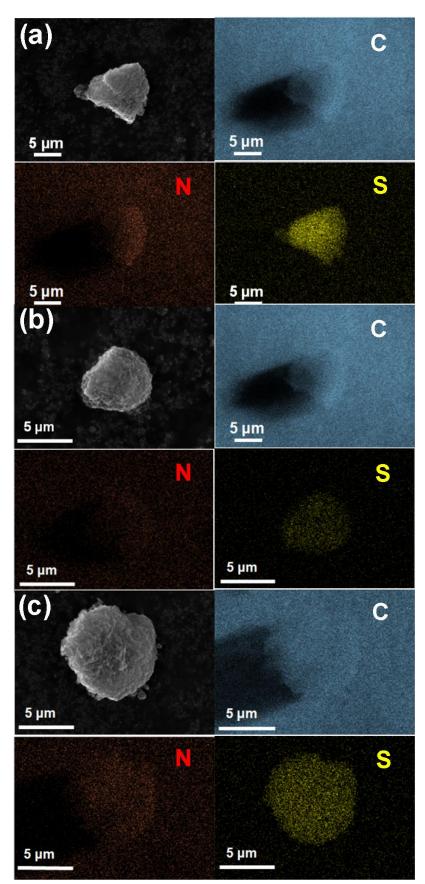


Figure S1. SEM-EDS images of NSMCC-650 (a), NSMCC-750 (b) and NSMCC-850 (c), respectively.

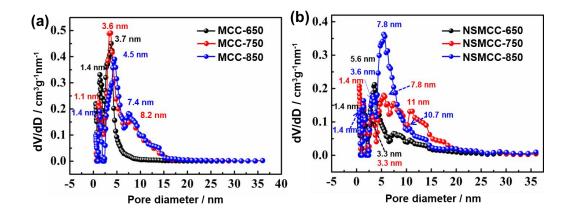


Figure S2. Pore size distribution curves of MCC (a) and NSMCC (b) materials.

Samples	S_{BET} $(m^2 g^{-1})$	S_{micro} (m ² g ⁻¹)	S_{meso} (m ² g ⁻¹)	Micro/mesoporous ratio (%)	V_{total} (cm ³ g ⁻¹)
MCC-650	1529.1	1108.6	420.5	72.5 /27.5	1.449
MCC-750	1210.2	1175.8	34.4	97.2 /2.8	2.355
MCC-850	1169.5	890.7	278.8	76.2 /23.8	2.122
NSMCC-650	745.8	568.6	177.2	76.2 /23.8	1.197
NSMCC-750	917.3	796.7	120.6	86.9/13.1	2.050
NSMCC-850	1074.6	868.6	206.0	80.8 /19.2	2.364

 Table S1 Specific surface area and pore volume data of MCC and NSMCC materials.

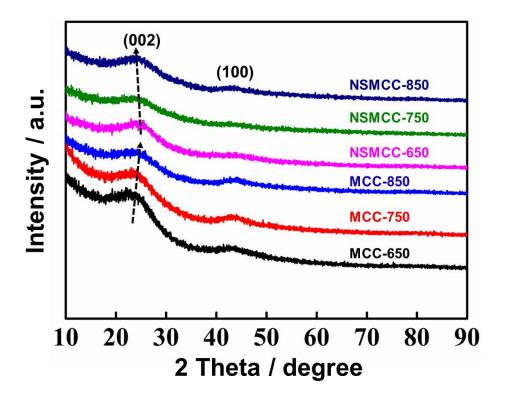


Figure S3. XRD patterns of MCC and NSMCC materials.

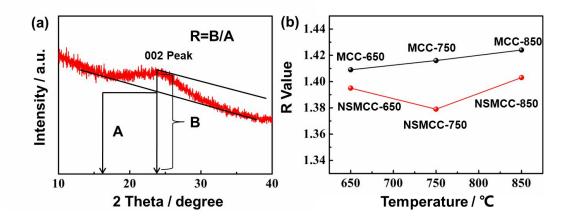


Figure S4. (a) Illustration of a calculation method for empirical R values. (b) Empirical R values of MCC and NSMCC materials prepared from different temperatures.

Samples	R values	Samples	R values
MCC-650	1.409	NSMCC-650	1.395
MCC-750	1.416	NSMCC-750	1.379
MCC-850	1.424	NSMCC-850	1.403

 Table S2 The calculation results of R values.

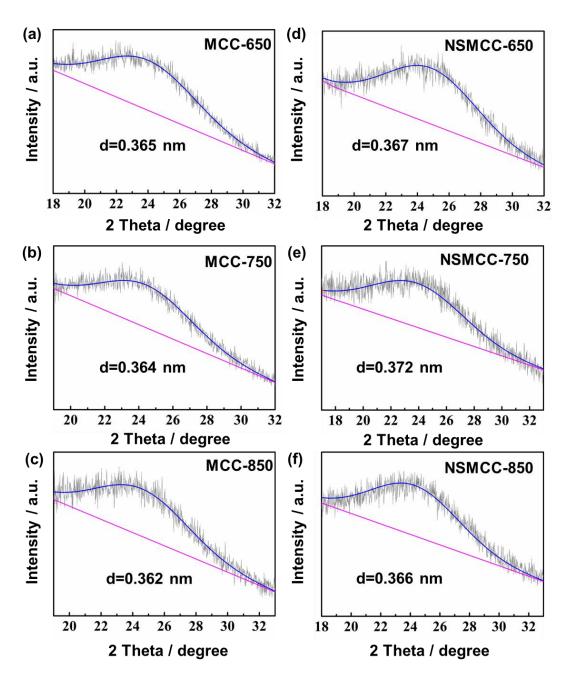


Figure S5. Fitting results of XRD measurements of MCC and NSMCC materials.

Samples	d ₀₀₂	I_D/I_G
MCC-650	0.365	2.18
MCC-750	0.364	2.31
MCC-850	0.362	2.64
NSMCC-650	0.367	2.13
NSMCC-750	0.372	2.07
NSMCC-850	0.366	2.49

Table S3 Fitted data from XRD and Raman results of MCC and NSMCC materials.

	S 2p _{3/2} (at.%)	Position (eV)	S 2p _{1/2} (at.%)	Position (eV)	Oxidized sulfur(at.%)	Position (eV)
NSMCC-650	0.71	164.0	0.75	165.1	0.47	167.7
NSMCC-750	1.72	164.1	1.96	165.2	1.38	167.4
NSMCC-850	1.03	164.0	1.22	165.1	1.1	167.8

 Table S4a Fitted S 2p XPS results for NSMCC samples.

 Table S4b Fitted N 1s XPS results for NSMCC samples.

	N-6 (at.%)	Position (eV)	N-5 (at.%)	Position (eV)	N-Q (at.%)	Position (eV)
NSMCC-650	0.67	398.6	0.75	400.6	0.47	402.1
NSMCC-750	1.72	398.6	1.96	400.8	1.38	402.6
NSMCC-850	1.03	398.6	1.22	400.9	1.10	403.0

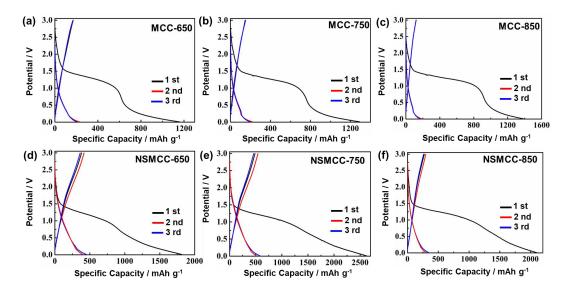


Figure S6. Charge-discharge curves of MCC and NSMCC materials.

Samples	R ₁ (ohm)	R ₂ (ohm)	R ₃ (ohm)
MCC-650	5.396	6.258	684.1
MCC-750	4.728	5.941	1163.0
MCC-850	4.605	5.306	1386.0
NSMCC-650	5.491	5.210	184.5
NSMCC-750	4.970	5.070	144.4
NSMCC-850	5.029	6.080	228.2

 Table S5 Simulated impedance of MCC and NSMCC materials.

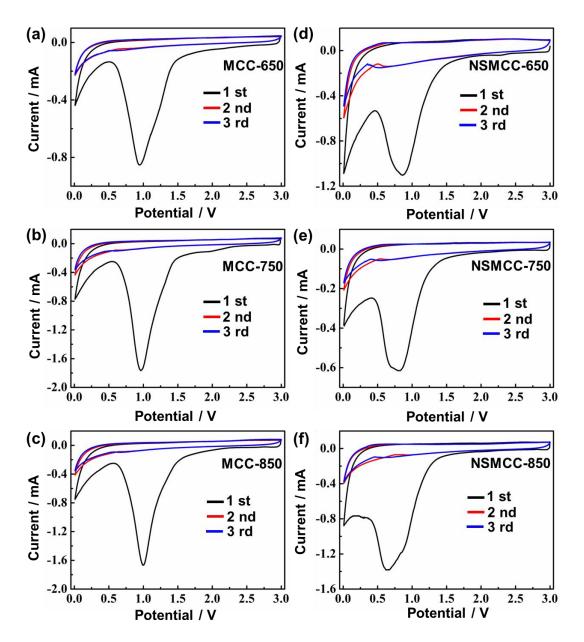


Figure S7. CV measurement results of MCC (a-c) and NSMCC (d-f) materials.

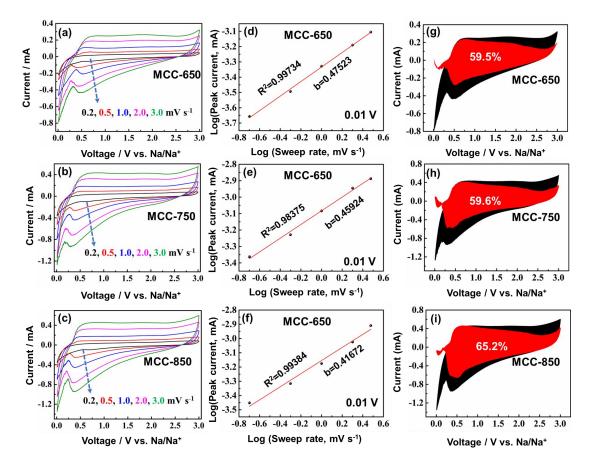


Figure S8. CV measurements of MCC materials at different rate scans (a-c). (d-f) are the b values of MCC materials. Capacitive contribution calculation results of MCC materials at a rate scan of 3.0 mV/s (g-i).

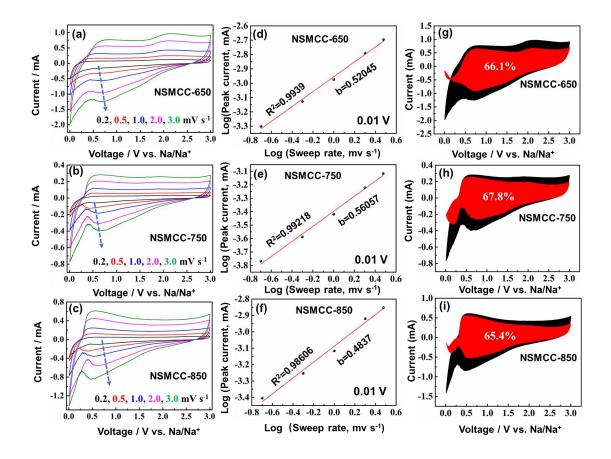


Figure S9. CV measurements of NSMCC materials at different rate scans (a-c). (d-f) are the b values of NSMCC materials. Capacitive contribution calculation results of NSMCC materials at a rate scan of 3.0 mV/s (g-i).

Samples	b values	capacitance ratios (%)
MCC-650	0.475	59.5
MCC-750	0.459	59.6
MCC-850	0.417	65.2
NSMCC-650	0.520	66.1
NSMCC-750	0.561	67.8
NSMCC-850	0.484	65.4

Table S6 The b values and capacitance ratios data of MCC and NSMCC samples.

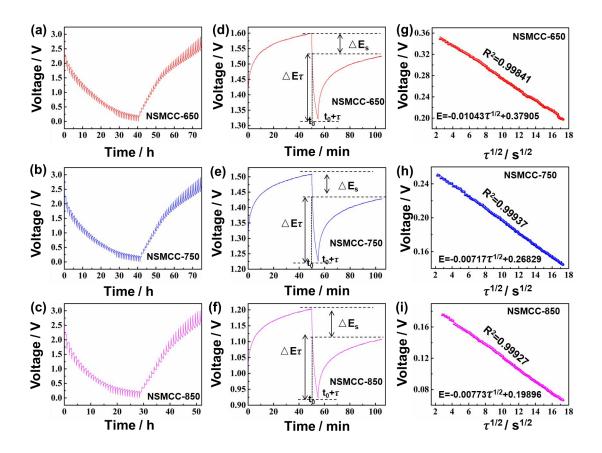


Figure S10. GITT titration curves (a-c) of MCC materials, titration curve of single GITT (d-f) and the relation of discharge voltage E vs $\tau^{1/2}$ (g-i).

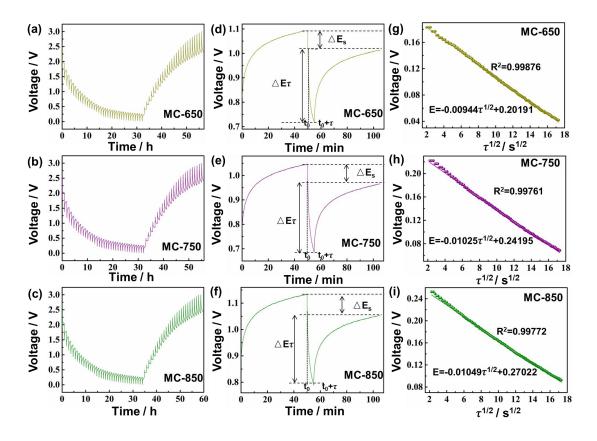


Figure S11. GITT titration curves (a-c) of NSMCC, titration curve of single GITT (d-f) and the relation of discharge voltage E vs $\tau^{1/2}$ (g-i).

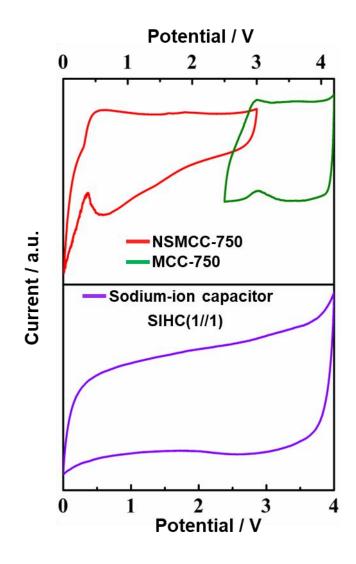


Figure S12. CV results of NSMCC-750, MCC-750 and SIHC(1//1).

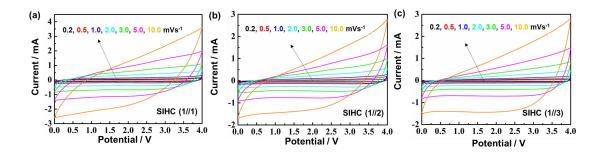


Figure S13. CV curves of SIHC(1//1) (a), SIHC(1//2) (b) and SIHC(1//3) (c) at various scan rates

from 0.2 to 10.0 mV s⁻¹.

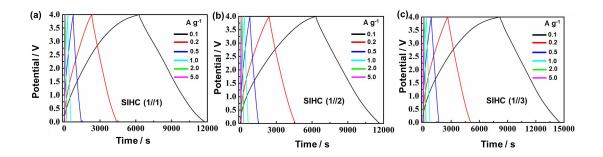


Figure S14. GCD curves of SIHC(1//1) (a), SIHC(1//2) (b) and SIHC(1//3) (c) are described at current densities from 0.1 A g^{-1} to 5.0 A g^{-1} .

Samples	0.1 A g ⁻¹	0.2 A g ⁻¹	0.5 A g ⁻¹	1 A g ⁻¹	2 A g ⁻¹	5 A g ⁻¹
MCC-650	87.5	78.2	67.6	46.3	37.4	28
MCC-750	103.7	98.2	94.5	90.6	85.3	78.8
MCC-850	98.3	95.2	91.3	86.7	81.2	73.6
NSMCC-650	98.6	88.2	72.4	56.3	44.2	32.6
NSMCC-750	96	92.6	88.8	82.4	77.1	68.4
NSMCC-850	99.4	97.9	93.1	92	87	79.4

Table S7 Specific capacities (F g⁻¹) of materials MCC and NSMCC materials at different current densities.

	0.1 A g ⁻¹	0.2 A g ⁻¹	0.5 A g ⁻¹	1 A g ⁻¹	2 A g ⁻¹	5 A g ⁻¹
SIHC(1//1)	80.2	52.8	43.8	36.8	28.0	21.1
SIHC(1//2)	52.2	37.0	30.5	26.5	22.9	18.0
SIHC(1//3)	48.25	33.5	27.3	23.5	20.4	16.5

 Table S8 Specific capacities (F g⁻¹) of SIHCs at different current densities.

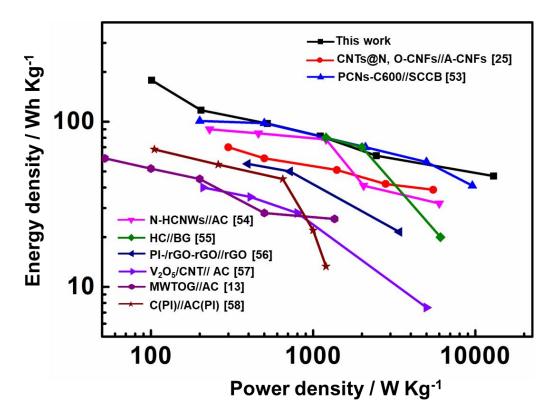


Figure S15. Ragone plots comparing SIHCs fabricated in our studies with other reported SIHCs.

System	specific capacitances (F g ⁻¹) at different current densities (A g ⁻¹)						_
(anode//cathode)	0.1	0.2	0.5	1.0	2	5	Ref.
	(A g ⁻¹)	$(A g^{-1})$	$(A g^{-1})$	(A g ⁻¹)	$(A g^{-1})$	$(A g^{-1})$	
NSMCC-750//MCC-750	80.17	52.81	43.82	36.84	27.97	21.12	This work
SIHC (1//1)	(F g ⁻¹)	(F g ⁻¹)	(F g ⁻¹)	(F g ⁻¹)	(F g ⁻¹)	(F g ⁻¹)	This work
PCNs-C600//SCCB	40.29	36.95	33.53	29.64	NI/A	19.55	52
PCINS-COUD//SCCD	(F g ⁻¹)	(F g ⁻¹)	(F g ⁻¹)	(F g ⁻¹)	$N/A (F g^{-1})$	(F g ⁻¹)	53
CNTs@N, O-CNFs//A-CNFs	31	N/A	N/A	N/A	20.2	N/A	25
CINIS(WIN, O-CINFS//A-CINFS)	(F g ⁻¹)				(F g ⁻¹)		23

Table S9 Specific capacitances of SIHC (1//1) and other reported materials at different current densities.

Table S10 Comparisons of the electrochemical performances of full-cell SIHCs.

System (anode//cathode)	Energy density (Wh Kg ⁻¹)	Power density (W Kg ⁻¹)	Capacity retention(%)/Cycle number/Current density(A/g)	Ref.
NSMCC-750//MCC-750 SIHC (1//1)	46.9	12957.6	64.5%/10000/2	This work
PCNs-C600//SCCB	41	9600	83%/8000/1	53
CNTs@N,O-CNFs//A-CNFs	38.7	5500	48.6%/5000/0.5	25
N-HCNWs//AC	37.5	9000	70%/2000/2	54
HC//BG	20	6100	97%/5000/1	55
PI-/rGO-rGO//rGO	21.5	3400	60%/1000/0.1	56
V2O5/CNT// AC	7.5	5000	N/A	57
MWTOG//AC	25.8	1357	90%/10000/3.4	13
C(PI)//AC(PI)	13.3	1200	82.4%/1000/0.4	58